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Atty. Dkt. No. 017700-0187

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takeshi HIKATA

Title: METHOD OF PRODUCING CARBON NANOSTRUCTURE

Appl. No.: Unassigned

International Filing Date: 05/19/2005

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371(c) Date: 09/06/2006

Examiner: Unassigned

Art Unit: Unassigned

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Abstract are presented as a new Abstract attached to this document for insertion after the claim pages of the application (or to replace the previously submitted Abstract).

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: